



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hellig, et al.

Title: SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF

App. No.: 10/058,854 Filed: 01/28/2002

Examiner: William M. Brewster Group Art Unit: 2823

Atty. Dkt. No.: 1458.TT4962

May 13, 2003

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action mailed February 4, 2003, regarding the above captioned patent application, the Applicants hereby respectfully submit the following amendment and response.

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